



PATENT
Attorney Docket No. 2013P107

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Seong Deok Ahn et al.

Application No.: 10/672,013

Filed: September 26, 2003

Examiner: Richard R. Bueker

Art Unit: 1763

Confirmation No.: 7684

For: **Method and Apparatus Using Large-Area
Organic Vapor Deposition for Formation of
Organic Thin Films or Organic Devices**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

In response to the Office Action mailed December 1, 2006, in connection with the above referenced patent application, Applicants respectfully request entry of the following amendments and request reconsideration in view of the following remarks.